



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Tadahiro OHMI

Group Art Unit: 2811

Application No.: 10/700,466

Examiner: Thien F. Tran

Filed: November 5, 2003

Attorney Dkt. No.: 108390-00056

For: DEVICE HAVING A SILICON OXIDE FILM CONTAINING KRYPTON

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: September 7, 2004

Sir:

In response to the Office Action dated August 6, 2004, the period for response expiring on September 6, 2004, a Federal Government holiday, Applicants hereby elect Group I, claim 16, drawn to a semiconductor device.

Applicants reserve the right to file one or more divisional applications directed to the non-elected claims.

It is believed that extensions of time are not required, beyond those that may otherwise be provided for in accompanying documents. However, in the event that additional extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. § 1.136(a), and any

fees required therefor are hereby authorized to be charged to our Deposit Account
No. 01-2300, referencing docket number 108390-00056.

Respectfully submitted,



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RKC:tdd

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